

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 856063.754		APPLICATION NO. 10/695,479	
<div style="display: flex; align-items: center; justify-content: center;"> <div style="border: 1px solid black; border-radius: 50%; padding: 10px; text-align: center; margin-right: 10px;"> OTPE APR 0 6 2005 PATENT & TRADEMARK OFFICE </div> <div> INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) </div> </div>				APPLICANTS Danilo Mascolo et al.			
				FILING DATE October 28, 2003		GROUP ART UNIT 2818	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
M	AA 5,997,958	12/07/99	Sato et al.	427	468		
	AB 6,057,556	05/02/00	Gubin et al.	257	39		
	AC 6,313,479	11/06/01	Zhang et al.	257	14		
	AD 2003/0102444	06/05/03	Deppert et al.	250	492.22		
M	AE 2003/0048619	03/13/03	Kaler et al.	361	760		
	AF						
	AG						
	AH						
	AI						
	AJ						
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION			
				YES	NO		
M	AK WO 03/016209 A1	02/27/03	WIPO				
	AL						
	AM						
	AN						
	AO						
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
M	AP	Hori, M., et al., "Sub-5 nm Gold Dot Formation Using Retarding-Field Single Ion Deposition," <i>Applied Physics Letters</i> 73(22):3223-3225, November 30, 1998.					
	AQ						
	AR						
EXAMINER				DATE CONSIDERED			
				5/22/05			
* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).							